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Attorney Docket Number

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			U.S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number Number - Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
V.		U00N 40/000,005	01-25-2004	rancoff	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	т∘
æ		ES 2142752	12-01-2000	Universidad Politecnica de Madrid		

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (imagazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, etc.	
7		Benítez, P. "Chapter 6: The SMS design method in three dimensions", from Conceptos avanzados de óptica anidólica: diseño y fabricación, PhD dissertation, UPM, (1998).	
		Benitez, P.; Mohedano, R.; Minano, J. "Design in 3D geometry with the Simultaneous Multiple Surface design method of Nonimaging Optics" Instituto de Engergia Solar, E.T.S.I. Telecomunicacion, Universidad Politecnica, 28040. Madrid, Spain. July 1999.	
1		International Search Report, PCT/US03/38240	

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